

A B S T R A C T

Provided is a storage device capable of appropriate temperature control.

5 According to one embodiment, a storage device includes a prober and a stocker. The prober writes data to or reads data from a semiconductor wafer that includes a plurality of non-volatile memory chips. The stocker stores a plurality of the semiconductor wafers that are detached from the prober. The prober includes
10 a first temperature control system. The first temperature control system raises temperature of the semiconductor wafer to a first temperature or higher. The stocker includes a second temperature control system. The second temperature control system cools
15 the semiconductor wafer to a second temperature or lower than the first temperature.